

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Toshifumi SUGANAGA

Serial No.:

Group Art Unit:

Filed: March 30, 2001

Examiner:

#2



For: EXPOSURE APPARATUS, EXPOSURE METHOD AND SEMICONDUCTOR DEVICE
FABRICATED WITH THE EXPOSURE METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

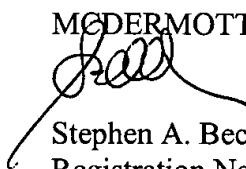
In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.